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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hidetaka Higashino et al.

Serial No.:

Filed:

For: METHOD OF PRODUCING GAS
DISCHARGE PANEL

Examiner:

Group Art Unit:

Irvine, CA 92614

January 19, 2001

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Prior to an examination on the merits of the above-identified application, please enter the following amendments:

IN THE CLAIMS:

Please amend the claims as follows:

Claim 41, line 2, delete "one of Claims 1 to 40" and insert --Claim 1--;

Claim 44, line 2, delete "one of Claims 1 to 40" and insert --Claim 1--.

Please add the following newly-drafted Claims 48 and 49.